

Notice of References Cited

Application/Control No.

10/789,119

Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

SHANTELL HEIBER

Art Unit

2617

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0066082	04-2003	Kliger et al.	725/80
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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FOREIGN PATENT DOCUMENTS

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